

<b>Notice of References Cited</b>	Application/Control No. 10/672,242	Applicant(s)/Patent Under Reexamination WEIGEL ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,638,478	10-2003	Treu et al.	422/44
*	B	US-6,284,131	09-2001	Hogard et al.	210/143
*	C	US-5,836,908	11-1998	Beden et al.	604/29
*	D	US-4,894,150	01-1990	Schurek et al.	210/101
*	E	US-4,728,433	03-1988	Buck et al.	210/646
*	F	US-6,579,253	06-2003	Burbank et al.	604/5.01
*	G	US-5,211,849	05-1993	Kitaevich et al.	604/5.04
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	X	

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